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BOX AFTER FINAL

In re the Application of:

Hae-seok PARK et al.

Art Unit: 2862

Serial No. 10/763,394

Examiner: David M. Schindler

Filed: January 26, 2004

Confirmation No. 4583

For: FLUXGATE SENSOR INTEGRATED IN A
SEMICONDUCTOR SUBSTRATE AND
METHOD FOR MANUFACTURING THE
SAME

Attorney Docket No. 277/044

AMENDMENT UNDER 37 C.F.R. § 1.116

Mail Stop: BOX AF
Commissioner for Patents
United States Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office Action Made Final dated June 7, 2006, the following
amendments and remarks are respectfully submitted in connection with the above-identified
application:

Amendments to the Claims are reflected in a listing of claims, which begins on page 2
of this paper.

Remarks begin on page 12 of this paper.